Notice of References Cited

Application/Control No

10/033,394

Examiner

Khiem D Nguyen

Applicant(s)/Patent Under Reexamination LEE ET AL.

Art Unit
Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Δ	∪S-5,599,734	02-1997	Byun et al.	438/143
	8	∪S-			
	С	US-			
	D	US-			
	Ε	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	11					
	0					
	Ρ					
	O					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

	NOW-FATENT BOODINENTS					
*	* Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	IEEE 2000, "Phosphorus Ion Shower Implantation for Special Power IC Applications", F. Kroner, R.Schork, L. Frey, A. Burenkov, H. Ryssel, pages 476-479.				
	V					
	w					
	3.					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.